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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

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New York, New York

Date: November 20, 2006

Serial No.: 10/726,300

Group Art Unit:

Date Filed: December 1, 2003

For: THIN FILM DEPOSITING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on December 1, 2003.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,



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